



500.39240X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: INOUE et al.
Serial No.: 09/698,185
Filed: October 30, 2000
For: SEMICONDUCTOR DEVICE AND METHOD FOR
MANUFACTURING THE SAME
Group: 2827
Examiner: L. Thai

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AMENDMENT

Box AF
Assistant Commissioner
for Patents
Washington, D.C. 20231

March 17, 2003

Sir:

In response to the Final Office Action dated October 16, 2002, the period of response for which extension is requested by the attached Petition for Extension of Time, please amend the above-identified application as follows:

In the Claims:

Please cancel claims 20-35 without prejudice.

Please add new claims 36-59 as follows:

-- 36. A semiconductor apparatus comprising a semiconductor device having circuit electrodes aligned centrally of the semiconductor apparatus, a first electrically insulating layer formed on said semiconductor device with said circuit electrodes being exposed from said first insulating layer, a second electrically insulating layer formed on said first insulating layer, external connection terminals formed on said